

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	MULTILAYER STRUCTURE FOR ABSORBING ELECTROMAGNETIC WAVE AND MANUFACTURING METHOD THEREOF	
Application Number :		
Date :		
First Named Applicant:	Mr. Li-Hsien Yen	
Confirmation Number:		
Attorney Docket Number:	10026-US-PA-0C	
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Submitted By:		Elec. Sign.
Dr. Belinda Lee Registered Number: 46,863		/Belinda Lee/ Sign. Capacity Agent

Documents being submitted:	Files
us-fee-sheet	10026CA-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-request	10026CA-usrequ.xml us-request.dtd us-request.xsl
application-body	10026CA.xml application-body.dtd Image1.tif Image2.tif Image3.tif Image4.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl wipo.ent
application-body-pdf-wrap	10026CA-pdf-wrap.xml
abstract-pdf	10026CA-abst.pdf
claims-pdf	10026CA-clms.pdf
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drawings-pdf	10026CA-draw.pdf
us-declaration	10026declaration1.tif
us-declaration	10026declaration2.tif
Comments	

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